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Appl. No. 10/823,116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/823,116  
Filing Date ..... April 12, 2004  
Inventor..... Kevin J. Torek et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1765  
Examiner ..... Deo, Duy Vu Nguyen  
Attorney's Docket No. .... MI22-2559  
Title: Methods of Removing Material from a Semiconductor Substrate

RESPONSE TO NOVEMBER 10, 2004 OFFICE ACTION

To: Mail Stop Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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AMENDMENTS

Introductory Comments

In response to the Office Action of November 10, 2004, applicant amends and remarks as follows.

01/26/2005 JADD01 00000033 10023116

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